FORM PTO 1449 (modified)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

LIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

ATTY DOCKET NO.	APPLICATION NO.
35.C14272	09/512,360

APPLICANT

HIDESHI KAWASAKI

FILING DATE	GROUP
February 24, 2000	2817

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

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FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
KJK		9-134666	5/20/97	Japan			Abstract
KJK		7-235255	9/5/95	Japan			Abstract
KJK		0 660 357 A1	6/28/95	Japan			English

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

KJK		C.A. Spindt et al., "Physical Properties of Thin Films of Thin-film Field Emission Cathodes with Molybdenum Cones", J. Applied Physics, Vol. 47, No. 12, Dec. 1976, pp. 5248-5263.
		C.A. Mead, "Operation of Tunnel-Emission Devices," J. Applied Physics, Vol. 32, No. 4, April 1961, pp. 646-652.
		W.P. Dyke et al., "Field Emission", Advances in Electronics and Electron Physics, Vol. VIII, 1956, pp. 89-185.
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		G. Dittmer, "Electrical Conduction and Electron Emission of Discontinuous Thin Films", Thin Solid Films, 9, 1972 pp. 317-328.
		M. Hartwell et al., "Strong Electron Emission From Patterned Tin-Indium Oxide Films", IEDM, 1975, pp. 519-521.
KJK		H. Araki, et al., "Electroforming and Electron Emission of Carbon Thin Films", Journal of the Vacuum Soc. of Japan, Vol. 2-6, No. 1, 1983, pp. 22-29 (with English Abstract on p. 22).

EXAMINER	Kenneth J. Ramsey	DATE CONSIDERED	9/6/0~
	Primary Examiner		

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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